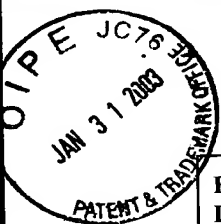


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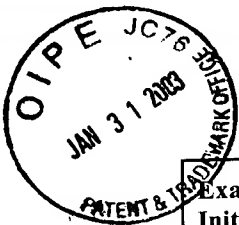
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JB	A ✓	Opposition filed by Glaverbel	
JB	B ✓	Opposition filed by Pilkington PLC	RECEIVED
JB	C ✓	Opposition filed by Toto LTD.	FEB 4 2003
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JB	2 ✓	EP 0581 216, Okada et al., February 2, 1994.	Document D2 cited in the Opposition under Tab A; Document D17 cited in the Opposition under Tab C
JB	3 ✓	Preparation of TiO <sub>2</sub> Fine Particles Supported on Silica Gel as Photocatalyst, Yasumori et al., Journal of the Ceramic Society of Japan, 102 (1994).	Document D5 cited in the Opposition under Tab A
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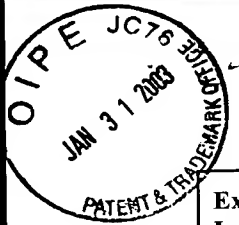
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JB	43	04/03/00 Letter from Mrs. Colette Ward, Patent Litigation Enquiries, British Library.	Document CW1 cited in the Opposition under Tab B
JB	44	Table showing values of roughness (Root Mean Square) of various coated glass samples available to the public at the priority date of EP 850 204.	Document TIM1 cited in the Opposition under Tab B

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